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Attorney Docket No.:  
Berkey 8-8-2A

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Berkey et al.

Serial No: 09/876,194

Filing Date: June 6, 2001

Title: PROJECTION LITHOGRAPHY  
PHOTOMASK BLANKS,  
PREFORMS AND METHOD OF  
MAKING

Group Art Unit: 1756

Examiner: ROSASCO, Stephen D

RESPONSE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO THE EXAMINER'S OFFICE ACTION**

In response to the Office Action dated July 24, 2003, paper No. 6 in the above-captioned application, please enter the following Remarks.

No amendment is being made to the application in this paper.

Remarks begin on page 2 in this paper.

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